



# PICALO

PACIFIC INTERNATIONAL CONFERENCE  
ON APPLICATIONS OF LASERS & OPTICS

March 23-25, 2010  
Shangri-La Hotel – Wuhan  
People's Republic of China

# ADVANCE *Program*

**GENERAL CHAIR:**

*Xiaoyan Zeng*, Huazhong University of Science & Technology, Wuhan, People's Republic of China

**GENERAL CO-CHAIRS:**

*Bo Gu*, IPG Photonics Corporation, Oxford, Massachusetts, USA

*Yongfeng Lu*, University of Nebraska-Lincoln, Lincoln, Nebraska, USA

*Andreas Ostendorf*, Ruhr-University of Bochum, Bochum, Germany

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*Minlin Zhong*, Tsinghua University, Beijing, People's Republic of China

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*Henry Peng*, GE (China) Research & Development Center Co. Ltd.,  
Shanghai, People's Republic of China

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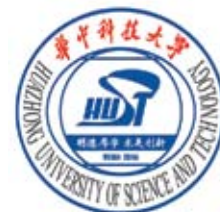
*Rangda Wu*, Chutian Laser Group, Wuhan, People's Republic of China

*Presented by Laser Institute of America in cooperation with  
Laser Processing Committee of China Optical Society (LPC-COS)  
and Huazhong University of Science & Technology.*



**Laser Institute  
of America**

*Laser Applications and Safety*



Register on the Web:  
[www.laserinstitute.org/picalo](http://www.laserinstitute.org/picalo)

# PICALO 2010 Conference Agenda

## Tuesday, March 23

- 8:00am Registration Desk Opens
- 9:00am Plenary Session
- 10:20am Morning Break
- 12:00pm Lunch
- 1:30pm LMP # 1: Cutting, Drilling and Machining  
LMP # 2: Welding I  
LMP # 3: Surface Modification I  
Micro # 1: Laser Fabrication of Photonic Devices
- 2:50pm Afternoon Break
- 5:00pm Welcome Reception

## Wednesday, March 24

- 8:00am Registration Desk Opens
- 9:00am LMP # 4: Welding II  
Micro # 2: Laser Direct Writing and Nano-devices  
Micro # 3: Laser Micromachining I and Simulations  
International Enterprise Summit  
Poster Presentation Gallery
- 10:20am Morning Break
- 12:00pm Lunch
- 1:30pm LMP # 5: Welding III  
LMP # 6: Additive Manufacturing  
Micro # 4: Laser Micro Structuring  
International Enterprise Summit
- 2:50pm Afternoon Break
- 5:30pm Laser Industry Vendor Program Reception & Tabletop Display

## Thursday, March 25

- 8:00am Registration Desk Opens
- 9:00am LMP # 7: Industrial Applications  
LMP # 8: Surface Modification II  
LMP # 9: Modeling and Simulation  
Micro # 5: Ultrafast Laser Processing  
Poster Presentation Gallery
- 10:20am Morning Break
- 12:00pm Lunch
- 1:30pm LMP # 10: Lasers, Systems and Optics  
LMP # 11: Welding IV  
LMP # 12: Additive Manufacturing and Surface Modification  
Micro # 6: Micromachining II and Novel Laser Sources
- 2:50pm Afternoon Break
- 6:00pm Closing Banquet

\*Program subject to change

**GENERAL CHAIR:**  
*Xiaoyan Zeng*

**LIA PRESIDENT:**  
*Nathaniel Quick*

**LIA EXECUTIVE DIRECTOR:**  
*Peter Baker*

**LIA DIRECTOR OF CONFERENCES:**  
*Gail Loiacono*



## PICALO ADVANCE PROGRAM

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### Special Thanks to the PICALO 2010 Cooperating Societies

**Beijing Optical Society**  
**Chinese Journal of Lasers**  
**European Laser Institute**

**Association of Laser Users**  
**European Optical Society**



**Xiaoyan Zeng,**  
Huazhong University  
of Science & Technology  
Wuhan, People's Republic of China

*Welcome to PICALO 2010 in Wuhan, China's Optical Valley.* PICALO is the bridge connecting researchers, engineers, equipment suppliers, end-users and industry personnel, bringing them face to face to share knowledge, experiences and visions. Laser experts and entrepreneurs with fresh results and the latest progress will converge with end-users in China and Asia to form valuable professional relationships. PICALO 2010 includes two separate conferences, the Laser Materials Processing Conference and the Laser Micro, Nano, and Ultrafast Fabrication Conference, in addition to the International Enterprise Summit, a business-focused forum highlighting laser industry development during the current global financial crisis. Your contributions are crucial to the success of these exciting events!

I invite you to come and enjoy the stimulating and beneficial academic environment and exciting technical program, while making new friends from laser engineering and business circles. Plan to arrive early and stay late for fabulous sightseeing opportunities in and around Wuhan.

PICALO 2010 is organized by Laser Institute of America (LIA) in cooperation with the Laser Processing Committee of China Optical Society (LPC-COS) and Huazhong University of Science and Technology. On behalf of the organizing committee and conference chairs, I would like to formally invite you to attend PICALO in March 23-25, 2010 in Wuhan.

## **Plenary Session : Superfast Laser / Laser Applications**

Although the Optical Valley is located in Wuhan, where the largest laser companies and laser processing system integrators in China are located, it is an unprecedented event for the city to host such a great event as PICALO 2010 during the best season of the year, with the presence of so many world class scientists and engineers with so many fresh ideas and techniques. This conference will provide rich information on advanced science and engineering in laser materials processing, and build a bridge strategically linking Wuhan, China with the rest of the world.

The PICALO 2010 plenary session highlights the theme of "superfast laser / laser applications". This plenary session starts with an impressive talk on multi-hundred-watt femtosecond lasers and their applications in material processing. This type of laser may bring significant novel results which may have profound impact on the future material processing techniques. Femtosecond lasers have significant impacts not only on material processing, but also on the analysis and characterization of different substances, especially in biomedical fields. With a special dispersion compensation scheme, a random scanning two-photon microscope is constructed which is able to track fast neuronal activities that could not be monitored with conventional techniques. The evolution of the femtosecond laser pulses after passing an AOD scanner, and the experiments with models to validate its applications in neuroscience will be presented in the second part of the plenary session.

Laser direct manufacturing of metallic components based on powder deposition has appeared for many years. Its applications have been limited to the fabrication of small metallic components. A challenging question is if it is possible to manufacture large metallic components and push technique into industrial applications. The third plenary talk from Beihang University will give us the answers.

### **Invited Plenary Speakers:**

**High-Power Ultra-short Pulse Laser Radiation: New Sources as Key Enablers for Emerging Applications (Keynote Presentation)**  
Ingomar Kelbassa, RWTH Aachen University

**Two-Photon Microscopic Biological Imaging with Femtosecond Laser Pulses**  
Shaoqun Zeng and Qingming Luo, Huazhong University of Science and Technology

**Laser Direct Manufacturing of High-Performance Large Titanium Structural Components for the Aerospace Industries: Challenges and Progresses**  
H.M. Wang, Beihang University

**Digital Microfabrication by Laser Forward Transfer**  
Alberto Pique, Naval Research Lab

**Special Thanks to the Following:**

<b>Eckhard Beyer</b>	Fraunhofer IWS, Dresden, Germany
<b>Milan Brandt</b>	Swinburne University of Technology, Melbourne, Australia
<b>Friedrich Dausinger</b>	Institut für Strahlwerkzeuge, Stuttgart, Germany
<b>Shusheng Deng</b>	Laser Processing Committee - China Optical Society, People's Republic of China
<b>Walter W. Duley</b>	University of Waterloo, Waterloo, Ontario, Canada
<b>Naoto Koshizaki</b>	NARC, National Institute of Advanced Industrial Science and Technology, Ibaraki, Japan
<b>Gnian Cher Lim</b>	Singapore Institute of Manufacturing Technology, Singapore
<b>Shangyang Lin</b>	Harbin Welding Institute, Harbin, People's Republic of China
<b>Wenjin Liu</b>	Tsinghua University, Beijing, People's Republic of China
<b>Jyoti Mazumder</b>	CLAIM, The University of Michigan, Ann Arbor, MI, USA
<b>Reinhart Poprawe</b>	Fraunhofer ILT, Aachen, Germany
<b>John Powell</b>	Laser Expertise Ltd., Nottingham, UK
<b>Chris Smallbone</b>	Welding Technology Institute of Australia, Silverwater, Australia
<b>William M. Steen</b>	The University of Liverpool, Liverpool, UK
<b>Maocai Wang</b>	Institute of Metal Research, Shenyang, People's Republic of China
<b>Youliang Wang</b>	Laser Processing Committee - China Optical Society, People's Republic of China
<b>Xichen Yang</b>	Tianjin Polytechnique University, Tianjin, People's Republic of China
<b>Xiao Zhu</b>	Huazhong University of Science and Technology, Wuhan, People's Republic of China
<b>Tiechuan Zuo</b>	Beijing University of Technology, Beijing, People's Republic of China

**Wednesday, March 24th**



**International Enterprise Summit**

Now that 2009 is behind us, people are looking ahead to 2010 searching for signs of economic recovery in the laser industry. The International Enterprise Summit has invited executives and experts from the laser industry worldwide to Wuhan, the "Optical Valley" of China to discuss the current status and future trends of our industry. This session's theme is "Advanced Lasers and Laser Processing Systems." CEOs and CTOs of laser industry will present their latest research and development activities, showcase their new products and predict the markets. The speakers will put forward their insights on how to break through the down turn economic cycle in order to be ready for the future growth. Don't miss this rare opportunity!

**Bo Gu,**  
**IPG Photonics Corporation,**  
**Oxford, MA, USA**



**Rangda Wu,**  
**Chutian Laser Group, Wuhan,**  
**People's Republic of China**

**Laser Industry Vendor Program Reception & Tabletop Display**

**Wednesday, March 24th, 5:30pm**

The Laser Industry Vendor Program gives vendors and conference attendees the opportunity to discuss equipment and applications in a relaxed setting. After completion of the technical sessions, share refreshments and product ideas with your colleagues and suppliers! Limited space is still available! For more information on participating as a vendor, contact Gail LoIacono at +1.407.380.1553 or email: [picalo@laserinstitute.org](mailto:picalo@laserinstitute.org).

The Laser Materials Processing Conference features the latest developments across the world in laser cutting, machining, surface modification, welding, additive manufacturing, laser modeling and simulation, drilling and forming and industrial applications. Technical sessions will include oral and poster presentations. In most subject areas, invited speakers from leading research groups and companies worldwide will present their recent findings and future prospects.

## Laser Materials Processing Conference Co-Chairs:

**Lin Li**, The University of Manchester, Manchester, UK

**Minlin Zhong**, Tsinghua University, Beijing, People's Republic of China



## Laser Materials Processing Conference Committee

**Pascal Aubry**, CEA, Arcueil, France

**Magdi Azer**, GE Global Research, Niskayuna, NY, USA

**Woong-Seong Chang**, RIST, Pohang, South Korea

**Genyu Chen**, Hunan Univ., Changsha, Hunan Province, People's Republic of China

**Yanbin Chen**, Harbin Institute of Technology, Harbin, People's Republic of China

**Shuili Gong**, BAMTRI, Beijing, People's Republic of China

**Bo Gu**, IPG Photonics Corporation, Oxford, MA, USA

**Paul Hilton**, TWI Ltd., Great Abington, Cambridge, UK

**Weidong Huang**, Northwestern Polytechnical Univ., Xian, People's Republic of China

**Takashi Ishide**, Mitsubishi Heavy Industries, Ltd., Takasago, Hyogo, Japan

**Jeng-Ywan Jeng**, National Taiwan Univ. of Science and Technology, Taipei, Taiwan, People's Republic of China

**Stefan Kaierle**, Fraunhofer ILT, Aachen, Germany

**Seiji Katayama**, Osaka Univ., Ibaraki, Osaka, Japan

**Ingomar Kelbessa**, RWTH Aachen Univ., Aachen, Germany

**Volodymyr Kovalenko**, National Technical Univ. of Ukraine, Kyiv, Ukraine

**Shang Yang Lin**, Harbin Welding Institute, Harbin, People's Republic of China

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**I. Manna**, LLT, India, India

**Isamu Miyamoto**, Osaka Univ., Osaka, Japan

**Edward Metzbow**, eamweld LLC, Alexandria, VA, USA

**Flemming Olsen**, Technical Univ. of Denmark, Lyngby, Denmark

**Bill O'Neill**, Univ. of Cambridge, Cambridge, UK

**Rui Vilar**, Instituto Superior Técnico, Lisboa, Portugal

**Dirk Petring**, Fraunhofer ILT, Aachen, Germany

**Edward Reutzel**, ARL, The Penn State Univ., State College, PA, USA

**Antti Salminen**, Lappeenranta Univ. of Technology, Lappeenranta, Finland

**Yusheng Shi**, Huazhong Univ. of Science and Technology, Wuhan, People's Republic of China

**G. Sundararajan**, International Advanced Research Centre for Powder Metallurgy and New Materials, Andhra Pradesh, India

**Frank Vollertsen**, BIAS, Bremen, Germany

**Huaming Wang**, Beijing Univ. of Aeronautics and Astronautics, Beijing, People's Republic of China

**Kenneth Watkins**, The Univ. of Liverpool, Liverpool, UK

**Yixiong Wu**, Shanghai Jiaotong Univ., Shanghai, People's Republic of China

**Rongshi Xiao**, Beijing Univ. of Technology, Beijing, People's Republic of China

**Lijue Xue**, National Research Council of Canada, London, Ontario, Canada

**Yongqiang Yang**, Huanan Univ. of Technology, Guangzhou, Guangdong, People's Republic of China

**Jianhua Yao**, Zhejiang Univ. of Technology, Hangzhou, Zhejiang, People's Republic of China

**Y. Lawrence Yao**, Columbia Univ., New York, NY, USA

**Jianxun Zhang**, Xi'an Jiaotong Univ., Xi'an, People's Republic of China

**Yongkang Zhang**, Jiangsu Univ., Zhenjiang, People's Republic of China

**Wenwu Zhang**, GE Global Research, Schenectady, NY, USA

**Hongyu Zheng**, Singapore Institute of Manufacturing Technology, Singapore

**Norman Zhou**, Univ. of Waterloo, Waterloo, Ontario, Canada

## LMP Session 1: Cutting, Drilling and Machining Tuesday, March 23 • 1:30pm

*Session Co-chairs: Tony Hoult, IPG Photonics Corporation, West Coast Operations, Santa Clara, CA, USA; Dirk Petring, Fraunhofer ILT, Aachen, Germany*

### Cutting Thick Section Steels with Fiber Lasers (101)

*Tony Hoult, Randy Paura, IPG Photonics Corporation*

### Status of Laser Cutting of Metals with High Power Disk Lasers in Industrial Use (102)

*Hartmut Zefferer, Markus Lindemann, TRUMPF Laser und Systemtechnik GmbH; GüNther Weinmann, TRUMPF China (Hong Kong) Ltd.*

### Investigation of Profile Cutting on Glass Plates Using a Pulsed UV Laser System (103)

*Shih-Feng Tseng, Instrument Technology Research Center, National Applied Research Laboratories*

### The Influence of Double Pulse Laser on Drilling Speed and Quality (104)

*Xuejun Wang, Beijing 625 Institute, AVIC*

### Synthesis of Doped-Zno Nanowires by Laser Ablation and Their Application to Light Emitting Devices (Invited Presentation) (105)

*Tatsuo Okada, Kyushu University*

## Research on Single Pass Laser Crack-Free Cutting of Thick and Dense Ceramics (106)

Lingfei Ji, Beijing University of Technology; Yinzhou Yan, Yong Bao, Yijian Jiang, Institute of Laser Engineering, Beijing University of Technology

## Laser Scribing of Stainless Steel (Invited Presentation) (107)

Matti Manninen, Antti Salminen, Lappeenranta University of Technology

## Laser Machining of Alumina (Al<sub>2</sub>O<sub>3</sub>) Ceramic (108)

Mohammed Naeem, GSI Group, Inc. - Laser Division

## The Experimental Study on Recast Layer Removal of Metallic Material by Femtosecond Laser (109)

Chengjuan Yang, Xuesong Mei, Wenjun Wang, Gedong Jiang, Kedian Wang, Mingjiang Ding, Department of Mechanical Engineering, Xi'an Jiaotong University

## **LMP Session 2: Welding I**

**Tuesday, March 23 • 1:30pm**

Session Co-chairs: Eckhard Beyer, Fraunhofer IWS, Dresden, Germany; Shuili Gong, BAMTRI, Beijing, Peoples Republic of China

## Laser Absorption in High-Power Fiber Laser Welding of Stainless Steel and Aluminum Alloy (Invited Presentation) (201)

Seiji Katayama, Yousuke Kawahito, Naoyuki Matsumoto, Osaka University

## Effect of Wire Feed on the Dynamics of Keyhole and Molten Pool in Fiber Laser Welding Aluminum Alloy (202)

Yu Chun, Shengfu Yu, HUST

## Beam Shaping of Vertical Cavity Surface Emitting Laser Diodes by Aspheric Microlenses and Microlens Arrays (203)

Li-Gang Niu, Wei Gao, Xiao-Feng Lin, Qi-Dai Chen, Hong-Bo Sun, Jilin University

## Observation of Metal Transfer Process in Filler Wire Laser Welding of Aluminium Alloy (204)

Li Chen, BAMTRI

## Laser Welding of Aluminum Alloy and Mild Steel Sheets by Coupled Yag Laser Beams (205)

Souta Matsusaka, Jingguo Tang, Song Xue, Takehiro Watanabe, Chiba University

## Effect of Heat Input on Autogenous Welding of Duplex Stainless Steel (Invited Presentation) (206)

Antti Salminen, Lappeenranta University of Technology; Elin Westin, Outokumpu Oyj

## Improving Laser Beam Welding with Machine Learning (207)

Ingo Stork, Technische Universität München

## Review of the Fundamental Aspects of Focal Shift Effects and Countermeasures (208)

Thibault Bautze, Technical University of Munich

## Process Diagram for Fibre Laser Welding with Different Fibre Diameters (209)

Jongkol Iammi, National Metal and Materials Technology Center (Mtec); Janet Folkes, David Hann, The University of Nottingham

## **LMP Session 3: Surface Modification I**

**Tuesday, March 23 • 1:30pm**

Session Co-chairs: Kenneth Watkins, The University of Liverpool, Liverpool, Great Britain; Minlin Zhong, Tsinghua University, Beijing, People's Republic of China

## Laser Surface Engineering for Corrosion Protection (Invited Presentation) (301)

Zhu Liu, The University of Manchester

## Fast Fabrication of Aluminum Superhydrophobic Surfaces by Laser Processing (302)

Ming Zhou, Jiangsu University

## Laser Surface Alloying of Mn-Ni-Al Bronze for Cavitation Erosion Resistance (303)

Po Kee Wong, Zhichao Cheng, Chi Tat Kwok, Department of Electromechanical Engineering, Faculty of Science and Technology, University of Macau; Fai Tsun Cheng, Department of Applied Physics, The Hong Kong Polytechnic University; Hau Chun Man, Department of Industrial and Systems Engineering, The Hong Kong Polytechnic University

## Microstructure and Properties of Laser Cladding Tic-H13 Composite Coating (304)

Fanzhi Kong, Jianhua Yao, Xiaodan Tang, Chenghua Lou, Zhejiang University of Technology

## Laser Alloying of Al with Mixed Ni, Ti and SiC Powders (305)

Luyolo Mabhali, Csir National Laser Centre

## A Surface Structuring Approach to Laser Marking of Metals with Advanced Fiber Lasers (306)

Tony Hoult, IPG Photonics Corporation

## Laser Cladding of Mg<sub>65</sub>Cu<sub>25</sub>Y<sub>10</sub>/SiC Amorphous Composite Coatings on Az91D Magnesium Alloy for Improvement of Wear Resistance (307)

Kaijin Huang, Huazhong University of Science and Technology

## Optimization of Process Parameters with Neural Network Based on PSO for Laser Cladding (308)

Libin Ni, Hunan University

## Primary Study on the Oxidation of Tc4 Alloy Through Pulsed Nd:Yag Laser Irradiation (309)

Chen Changjun, Zhang Min, Chang Qing-Ming, Zhang Shi-Chang, Key Laboratory for Ferrous Metallurgy and Resources Utilization of Ministry of Education, Laser Processing Research Centre, Wuhan University of Science & Technology; Fei Qunxing, Key Laboratory for High Energy Density Beam Processing Technology, Beijing Aeronautical Manufacturing Technology Research Institute; Ma Hong-Yan, Department of Materials Engineering, Shenyang Institute of Aeronautical Engineering

## **LMP Session 4: Welding II**

**Wednesday, March 24 • 9:00am**

Session Co-chairs: Isamu Miyamoto, Osaka University, Hyogo, Japan; Rongshi Xiao, Beijing University of Technology, Beijing, People's Republic of China

## Applications of Diffraction-Limited High-Power Fiber Lasers (Invited Presentation) (401)

Eckhard Beyer, Berndt Brenner, Andreas Wetzig, Fraunhofer IWS, Dresden University of Technology

## Study on Periodical Oscillation of Plasma/Vapor Induced in High Power Fiber Laser Penetration Welding (402)

Jun Wang, Chunming Wang, Dejian Liu, Xiyuan Hu, Yangchun Yu, Xuanxuan Meng, School of Materials Science and Engineering, Huazhong University of Science and Technology.

## Experimental Investigation of the Melt Flow in Aluminum During Laser Welding with Magnetic Stirring (403)

Zhuo Tang, BIAS

## Comparison of High Power Yb-Fibre and Nd:Yag Lasers when Welding Ti-6Al-4V (404)

Jonathan Blackburn, Lin Li, The University of Manchester;  
Paul Hilton, Chris Allen, Steve Shi, TWI Ltd.

## Laser Process Monitoring: The Next Generation Approach (Invited Presentation) (405)

Stefan Kaierle, C. Franz, K. Kowalick, S. Mann, Fraunhofer ILT

## Net Shape Butt Welding of Mild Steel with a Fibre Laser (406)

Ramadan Eghlio, Andrew Pinkerton, Lin Li,  
The University of Manchester

## Stress Distribution Characteristics of Several Different Laser Welding Joints (407)

Bing Wu, BAMTRI

## Autogenous Laser Welding of Modified 9Cr-1Mo Steel Thick Plates (408)

Shanmugarajan Balasubramani, Krishnan P.S., Krishnaveni E., Padmanabham G., ARCI, Hemant Kumar, Shaju Albert, Bhaduri A.K., Igar

## LMP Session 5: Welding III

Wednesday, March 24 • 1:30pm

Session Co-chairs: Antti Salminen, Lappeenranta University of Technology, Lappeenranta, Finland; Jianhua Yao, Zhejiang University of Technology, Hangzhou, People's Republic of China

## Laser-Arc Hybrid Welding - Recent Advances in Research and Application (Invited Presentation) (501)

C. Thomy, Frank Vollertsen, BIAS

## Hybrid Laser Plasma Transferred Arc Rapid Manufacturing (Hlprm) and Characterization of Austenitic Stainless Steel Deposits (502)

P. Bhargava, C.P. Paul, C.H. Prem Singh, S.K. Mishra, L.M. Kukreja, Raja Ramanna Centre for Advanced Technology

## Spectral Analysis of the Arc Plasma in Laser-TIG Double-Side Welding of Aluminium Alloy (503)

Chen Yanbin, Zhao Yaobang, Lei Zhenglong, Harbin Institute of Technology

## Laser Assisted Hybrid (Cnc+Laser) Process for Grooving and Joining (504)

Hae Woon Choi, Keimyung University

## Welding Phenomena and Weld Penetration During Laser or Hybrid Welding (Invited Presentation) (505)

Seiji Katayama, Yousuke Kawahito, Masami Mizutani, Osaka University

## Review of Laser - Arc Hybrid Welding (506)

Rongshi Xiao, Wu Shikai, Kai Chen, Institute of Laser Engineering, Beijing University of Technology

## Effect of Welding Parameters on Formation of Laser Welding Aluminum-Lithium Alloys Sheet (507)

Wei Xu

## Effect of Heat Input on Microstructures and Mechanical Properties for Fiber Laser Welding 5A05 Aluminum Alloy with Filling Wire (508)

Yangchun Yu, Chunming Wang, Dejian Liu, Xiyuan Hu, Jun Wang, School of Materials Science and Engineering, Huazhong University of Science and Technology

## The Characteristics of Molten Pool During the Hybrid Laser-Arc Welding of 5A90 Al-Li Alloy (509)

Aiqin Duan, BAMTRI

## LMP Session 6: Additive Manufacturing

Wednesday, March 24 • 1:30pm

Session Co-chairs: Pascal Aubry, CEA, PARIS, France;  
Ingomar Kelbassa, RWTH Aachen University, Aachen, Germany

## Progresses on Direct Manufacturing by Laser Metal Deposition and Powder Bed Laser Melting (Invited Presentation) (601)

Pascal Aubry, CEA

## Development of Laser Metal Deposition for Gas Turbine Hot Section Components Repair (602)

James Chen, Ovidiu Timotin, Siemens Energy

## Selective Laser Melting of Pure Copper (603)

Jinhui Liu, Modern Manufacture Engineering Center; Heilongjiang University of Science & Technology

## Influence of Melt Pool Convection on Residual Stress Induced in Laser Cladding and Powder Deposition (604)

Alhaji Kamara, Lin Li, Sundar Marimuthu, Paul Mativenga, Wei Wang, The University of Manchester

## Additive Manufacturing of Small Geometrical Structures - An Analysis of the Potential Regarding the Laser Sintering Process of a High Temperature Resistant Thermoplastic (605)

Thomas Frick, Thomas Rechtenwal, Bayerisches Laserzentrum GmbH; Michael Schmidt, Lehrstuhl Für Photonische Technologien, Universität Erlangen-Nürnberg

## Application of Laser Powder Deposition for Turbine Blade Tip Cap Freeform Fabrication (606)

Huan Qi, GE Global Research

## The Application of Flexible Robotic Environment (FRE) to Laser Additive Manufacturing (LAM) (607)

James Sears, South Dakota School of Mines & Technology; Vojislav Kalanovic, Jovan Mirilovic, Control Systems Technology (CST)

## Direct Laser Deposition Forming of Ti-1023 Alloy (608)

Huaxue Li, BAMTRI, Key Laboratory for High Energy Density Beam Processing Technology

## Laser Additive Manufacturing for Wear Application Developments (609)

James Sears, South Dakota School of Mines & Technology

## Study on Directly Forming Metallic Component through Selective Laser Melting (610)

Rudi Li, Yusheng Shi, Jinhui Liu, Zhigang Wang, State Key Laboratory of Material Processing and Die & Mould Technology, Huazhong University of Science and Technology

## LMP Session 7: Industrial Applications

Thursday, March 25 • 9:00am

Session Co-chairs: Bo Gu, IPG Photonics Corporation, Oxford, MA, USA; Stefan Kaierle, Fraunhofer ILT, Aachen, Germany

## Industrial Applications of Fiber Lasers (701)

Bo Gu, IPG Photonics Corporation

## Laser Welding with Highly Integrated Sensor Technology - Implemented in Industry (702)

Markus Kogel-Hollacher, Precitec Optronik GmbH/Precitec KG

## Patch Repair by Laser Beam Welding - Weldability and Realisation (703)

Claudia Berkenhoff, Thomas Haubold, Rolls-Royce Deutschland GmbH; Klemens Bongard, Martin Dahmen, Stefan Kaierle, Fraunhofer-Institut für Lasertechnik

## Effects of Laser Drilling on Rate of Penetration (ROP) for Oil and Gas Wells Drilling (704)

Mahdi Bakhtbidar, Mohsen Ghorbankhani, Islamic Azad University of Omideh

## Application of the Laser Processing in Aerospace Industry (705)

Shuili Gong, BAMTRI

## Application of Laser Welding Technology in Shipbuilding (706)

Jian Huang, Zhuguo Li, Yan Cai, Shanghai Jiao Tong University, Shanghai Key Laboratory of Materials Laser Processing and Modification; Yixiong Wu, Shanghai Jiao Tong University, School of Materials Science and Engineering

## Laser Sources for Battery Welding in Electronic and Automotive Market Sectors (707)

Mohammed Naeem, GSI Group, Inc. - Laser Division

## Diode Laser Cladding in Repair Applications (708)

Silke Pflueger, Klaus Kleine, Laserline, Inc.

## Investigation into the Feasibility of Laser Milling and Drilling of Aerospace Carbon Fibre Reinforced Plastics (Cfrp) (709)

Paul French, Martin Sharp, Liverpool John Moores University; Mohammed Naeem, GSI Group, Inc. - Laser Division

## **LMP Session 8: Surface Modification II**

**Thursday, March 25 • 9:00am**

Session Co-chairs: Weidong Huang, Northwestern Polytechnical University, Xian, Peoples Republic of China; Zhu Liu, The University of Manchester, Manchester, Great Britain

## Nano Wc Powder Cold Surface Enhancing of Aluminium Alloy 5A06 Via Laser Shock Peening (801)

Minlin Zhong, Renjie Zhu, Tsinghua University

## Study of the Interface of Direct Metal Deposited H13 Tool Steel on Copper Substrate (802)

Mohammad Imran, Industrial Research Institute Swinburne

## High Temperature Performance of Laser Deposition Gh105 Layers on Nickel Base Super Alloy Blade (803)

Changsheng Dong, Minlin Zhong, Tsinghua University

## Microstructure and Properties of Laser Cladding Tic-H13 Composite Coating (804)

Fanzhi Kong, Jianhua Yao, Chenghua Lou, Xiaodan Tang, Qingming Ding, Zhejiang University of Technology

## Interfacial Reactions Between Ceramic Particles and Metal Matrix in the Laser Melt Injection Process (805)

Dejian Liu, Huazhong University of Science and Technology

## Desensitization of Austenitic and Duplex Stainless Steels by Laser Surface Melting (806)

Weng Kin Chan, Chi Tat Kwok, Kin Ho Lo, Zhichao Cheng, Department of Electromechanical Engineering, Faculty of Science and Technology, University of Macau

## What Happens When CO<sub>2</sub> Lasers Irradiate on Pzt Ceramics? (807)

Yijian Jiang, Yan Zhao, Beijing University of Technology

## Anti-Aggregating Study of Nanometer Coating Prepared by Laser Cladding (808)

Qunli Zhang, Jianhua Yao, Baorong Su, Zhejiang University of Technology

## **LMP Session 9: Modeling & Simulation**

**Thursday, March 25 • 9:00am**

Session Co-chairs: Mohammed Naeem, GSI Group, Inc. - Laser Division, Rugby, Great Britain; Gary Ng, SIMTech, Manchester, Great Britain

## 3D Transient Thermal Modelling and Experimental Observation of the Temperature Profile During Laser Assisted Machining of Ti-6Al-4V Alloy (901)

Nancy (Jihong) Yang, Swinburne University of Technology

## Modelling of the Formation of the Porous Structure by Selective Laser Sintering (902)

Furong Liu, Beijing University of Technology

## 3D Finite Element Analysis of the Thermally Induced Residual Stresses in the Laser-Gmaw Hybrid Welding of Butt Joints (903)

Fanrong Kong, Southern Methodist University

## Application of Crystal Plasticity Finite Element Method to Microscale Laser Peen Forming (904)

Wei Wang, Zhong Ji, Chao Zheng, Jing Liu, Shandong University

## Visualisation and Modelling of Combustion Effects at Laser Cutting of Mild Steel with Oxygen (905)

Peter Yudin, Grigory Ermolaev, Institute of Theoretical and Applied Mechanics S.B. R.A.S.; Eric Verna, Thomas Jouanneau, Air Liquide C.T.A.S.

## Three Dimensional Simulation of the Transient Process of Fiber Laser Keyhole Welding of Aluminum Alloys (906)

Pang Shengyong, Chen Liliang, Zhou Jianxin, Yin Yajun, Liu Jianhua, Hu Lunji, State Key Laboratory of Materials Processing and Die & Mould Technology, Huazhong University of Science and Technology

## Combined Numerical-Experimental Approach to Design Effective Gas-Dynamic Nozzles for Laser Cutting (907)

Oleg Kovalev, Peter Yudin, Alexander Zaitsev, Institute of Theoretical and Applied Mechanics S.B.R.A.S.

## Numerical Simulation of Geometry and Temperature Distribution in Thin Walls during Laser Rapid Manufacturing (908)

C.P. Paul, Atul Kumar, A.K. Pathak, M. Gupta, L.M. Kukreja, Raja Ramanna Centre for Advanced Technology

## **LMP Session 10: Lasers, Systems and Optics**

**Thursday, March 25 • 1:30pm**

Session Co-chairs: Markus Kogel-Hollacher, Precitec Optronik GmbH/Precitec KG, Rodgau, Germany; William O'Neill, University of Cambridge, Cambridge, Great Britain

## Progress in Cutting and Welding of Sheet Metal Assemblies in One Machine with the Laser Combi-Head (Invited Presentation) (1001)

Dirk Petring, Frank Schneider, Fraunhofer ILT; Harald Dickler, Laserfact GmbH



## Development of the Machines and Materials for Rapid Prototyping & Tooling Technologies and 3D Measurement (1002)

*Yusheng Shi, Qingsong Wei, Huazhong University of Science and Technology*

## Investigation of the Mechanism of Different Acoustic Signals Generated During Laser Welding (1003)

*Wei Huang, Radovan Kovacevic, Southern Methodist University*

## The Machine Vision of Powder Stream Concentration Field in Laser Remanufacturing Robot (1004)

*Yang Xichen, Chen Xiuping, Laser Processing Center, Tianjin Polytechnical University*

## Advanced Refractive Beam Shaping Optics for Advanced Laser Technologies (1005)

*Alexander Laskin, Molecular Technology (MolTech) GmbH*

## Beam Shape Optimization for Microwelding and Cutting (1006)

*Andy Appleyard, SPI Lasers*

## Real-Time Power Measurement for High Power Diode Laser (1007)

*Yu Song, Institute of Laser Engineering, Beijing University of Technology*

## Advantages of Adaptive Optics for Laser Metal Deposition in Comparison to Conventional Optics (1008)

*Bernd Burbaum, Chen Hong, Ingomar Kelbassa, Lehrstuhl fuer Lasertechnik, RWTH Aachen University*

## High Power Q-Switched Laser Architectures and CW Diode Pumped Gain Modules (1009)

*Jay Doster, Edward Stephens, Northrop Grumman Cutting Edge Optonics*

## **LMP Session 11: Welding IV**

**Thursday, March 25 • 1:30pm**

*Session Co-chairs: Yanbin Chen, Harbin Institute of Technology, Harbin, People's Republic of China; Lin Li, The University of Manchester, Manchester, Great Britain*

## Effect of Heat Input on Autogenous Welding of Duplex Stainless Steel (Invited Presentation) (1101)

*Antti Salminen, Lappeenranta University of Technology; Elin Westin, Outokumpu Oyj*

## Research on Laser-Resistance Hybrid Welding of Aluminum Alloy (1102)

*Xinge Zhang, Yanbin Chen, Liquin Li, Zhenglong Lei, Harbin Institute of Technology*

## Study on Welding Characteristics of Laser-Tig Double-Side Hybrid Welding (1103)

*Yanbin Chen, Zhenglong Lei, Harbin Institute of Technology*

## Influences of Welding Conditions on the Seam Quality During Hybrid Laser-GMAW Butt Welding of Thick Steel Plates (1104)

*Shanglu Yang, Southern Methodist University*

## The Interaction Between Laser Induced Plasma/Vapor and Arc Plasma During Fiber Laser-MIG Hybrid Welding (1105)

*Jun Wang, Chunming Wang, Dejian Liu, Xiyuan Hu, Yangchun Yu, Xuanxuan Meng, School of Materials Science and Engineering, Huazhong University College of Science & Technology*

## Development of a Laser Machine Vision System for Joint Tracking (1106)

*Wei Huang, Southern Methodist University*

## Study on the Stability of Laser Welding Process with Filler Wire (1107)

*Jing Yang, Xiaoyan Li, Shuili Gong, Li Chen, Fei Xu, Beijing Aeronautical Manufacturing Technology Research Institute, BAMTRI*

## Double Electric Path Mechanism of Nd:YAG Laser-Pulse MAG Hybrid Welding (1109)

*Wang Wei, Harbin Welding Institute*

## **LMP Session 12: Additive Manufacturing and Surface Modification**

**Thursday, March 25 • 1:30pm**

*Session Co-chairs: Henry Peng, GE (China) Research & Development Center Co. Ltd., Shanghai, People's Republic of China; Huaming Wang, BAAU, Beijing, People's Republic of China*

## Laser Net Shape Manufacturing of Ti6Al4V (1201)

*Guoshuang Cai, Xiaobin Chen, Yanmin Li, Yong Liu, Henry Peng, GE (China) Research & Development Center Co. Ltd.*

## Laser Cladding of Aluminium Using Tib2 Powder (1202)

*Sanjay Kumar, Sisa Pityana, CSIR, South Africa*

## Laser Surface Melting of 17-4 Ph Precipitation-Hardenable Stainless Steel (1203)

*Zhichao Cheng, Chi Tat Kwok, Kin Ho Lo, Department of Electromechanical Engineering, Faculty of Science and Technology, University of Macau*

## Study of Laser Cladding with Diode Laser Robotized System (1204)

*Jianhua Yao, Qunli Zhang, Zhejiang University of Technology; Volodymyr Kovalenko, Mykola Anyakin, National Technical University of Ukraine KPI*

## Study on Fibre Laser-MIG Hybrid Welding Process of Aluminum Alloy (1205)

*Jun Yan, Xiaoyan Zeng, Ming Gao, Huazhong University of Science and Technology*

## Improvement of High Temperature Oxidation Resistance of NiAl/Al2O3 Electroless Composite Coating by Laser Hardening (1206)

*Qingming Ding, Jianhua Yao, Fanzhi Kong, Zhejiang University of Technology*

## A Binocular Vision System To Measure Width And Height Of Deposited Material In Laser Net-Shape Manufacturing (1207)

*Guoshuang Cai, Xiaobin Chen, Henry Peng, GE Global Research; Yanmin Li, GE (China) Research & Development Center Co. Ltd.*

## Laser Surface Alloying of C-B-W-Cr Powders on Nodular Cast Iron Rolls (1208)

*Guifang Sun, Advanced Forming Technology Institute, Jiangsu University; Changsheng Liu, Northeastern University*

## Study on the Dimension Precision of the Metal Parts Fabricated by Selective Laser Melting Process (1209)

*Yusheng Shi, Li Wang, Zhigang Wang, Qingsong Wei, HUST*

New laser technologies for micro/nano/ultrafast fabrication and diagnosis continue to be the focus of academic research and industry applications. The explosion of new ideas in the photonics, electronics, energy conversion, material processing, microelectronics packaging and biomedical fields has created a unique need for fabrication and diagnostics at micro/nanoscales using continuous wave, nanosecond, picosecond and femtosecond lasers. The Laser Micro, Nano and Ultrafast Fabrication Conference at PICALO® 2010 is a global forum for engineers and scientists from a variety of industry segments and research institutes to meet and discuss use of laser micro/nano/ultrafast fabrication and diagnosis as a key technology for various applications. Attendees will find innovative ideas and solutions for micro/nano/ultrafast fabrication in opto- and microelectronics, electronics, microsystems, material processing and biomedical industries. This conference will highlight new and exciting achievements in structuring with highest precision using laser pulses from the nanosecond down to the picosecond and femtosecond time regime. Special sessions are dedicated to laser fabrication of photonic devices, laser direct writing of nanodevices, laser micromachining/microstructuring, ultrafast laser processing and novel laser sources. In this way, we may highlight the newest developments and their promising perspectives. Outstanding researchers will give keynote and invited presentations in order to provide a deep insight into the current research work in these fields.

## Micro, Nano and Ultrafast Fabrication Conference Co-Chairs:

**Yongfeng Lu**, University of Nebraska-Lincoln, Lincoln, Nebraska, USA  
**Henry Peng**, GE (China) Research & Development Center Co. Ltd.,  
Shanghai, People's Republic of China



## Laser Micro, Nano and Ultrafast Fabrication Committee

**Craig Arnold**, Princeton Univ., Princeton, NJ, USA  
**Dieter Baeuerle**, Johannes Kepler Univ., Linz, Austria  
**Jimin Chen**, Beijing Univ. of Technology, Chaoyang,  
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**Jun Duan**, Huazhong Univ. of Science and Technology,  
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**Bill Shiner**, IPG Photonics Corporation, Oxford, MA, USA  
**Koji Sugioka**, RIKEN, Saitama, Japan  
**Hong-Bo Sun**, Jilin Univ., Changchun,  
Jilin, People's Republic of China  
**Hai-Lung Tsai**, Univ. of Missouri-Rolla, Rolla, MO, USA  
**Kunihiko Washio**, Paradigm Laser Research Ltd, Machida,  
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**Xianfan Xu**, Purdue Univ., West Lafayette, IN, USA  
**Qingmao Zhang**, South China Normal Univ.,  
Guangzhou, People's Republic of China  
**Ming Zhou**, Jiangsu University, Zhenjiang, People's Republic of China

## Micro Session 1: Laser Fabrication of Photonic Devices

Tuesday, March 23 • 1:30pm

Session Co-chairs: **Lan Jiang**, Beijing Institute of Technology, Beijing, People's Republic of China; **Yongfeng Lu**, University of Nebraska - Lincoln, Lincoln, NE, USA

**Fabrication of Three-Dimensional Photonic Components in Transparent Substrates Using High-Repetition Rate Femtosecond Ultrafast Laser (Invited Presentation) (M101)**

*Kevin Chen, University of Pittsburgh*

**Synthesis and Characterization of ZnO Nano-Crystals by Nanoparticle-Assisted PLD and Their Application to Light Emitting Devices (Invited Presentation) (M102)**

*Tatsuo Okada, Kyushu University*

**Multiple Beam Ultrafast Laser Microprocessing (Invited Presentation) (M103)**

*Jian Cheng, Geoff Dearden, Stuart Edwardson, Eamonn Fearon, Zheng Kuang, Dun Liu, Walter Perrie, Shuo Shang, University of Liverpool*

**Ultrafast Laser Nanofabrication with Multimodal Spectroscopic Microscopy (M104)**

*Jianzhao Li, Dagmar Esser, Saeid Rezaei, Peter R. Herman, Electrical and Computer Engineering, University of Toronto*

**TBA (Invited Presentation) (M105)**

*Costas Grigoropoulos, University of California - Berkeley*

**Iterative Laser Bandgap Nanoengineering of III-V Quantum Well and Quantum Dot Wafers (Invited Presentation) (M106)**

*Jan J. Dubowski, Université de Sherbrooke*

**Laser Selective Patterning of Multi-Layers Thin-Film Organic Polymers for Solar Cell Interconnection (M107)**

*Shizhou Xiao, Ralf Nett, Andreas Ostendorf, Laser Applications Technology*

## Picosecond Laser Scribing for Thin-Film Solar Cell Manufacturing (M108)

*Gediminas Raciukaitis, Ekspla Ltd. & Institute of Physics; Paulius Gecys, Romualdas Trusovas, Institute of Physics; Raimundas Kondrotas, Ekspla Ltd.*

## Laser Machining Technology Applied in Solar Panels (M109)

*He Chao, Beijing University of Technology*

## Micro Session 2: Laser Direct Writing and Nano-Devices

Wednesday, March 24 • 9:00am

*Session Chair: Costas Grigoropoulos, University of California - Berkeley, Berkeley, CA, USA*

### Shaping Laser Interactions For Direct-Write Processing (Invited Presentation) (M202)

*Craig Arnold, Princeton University*

### Organic Light Emitting Material Direct Writing by Nanomaterial Enabled Laser Transfer (M203)

*Seung Hwan Ko, Yoonsoo Rho, Junyeob Yeo, Kaist; Heng Pan, Costas Grigoropoulos, UC- Berkeley*

### High Signal-To-Noise Ratio Four-Dimensional Storage Using Femtosecond Pulsed Laser (M204)

*Yanlei Hu, Wenhao Huang, University of Science and Technology of China*

### Micro-Patterning of Organic Thin-Film Electronic Devices by Ultra-Short Laser (Invited Presentation) (M205)

*Yoshiro Ito, Rie Tanabe, Department of Mechanical Engineering, Nagaoka University of Technology; Masahiro Ichihara, Eiichi Matsumoto, R&D Center, Tokki Corporation*

### Application of Adaptive Optics to Nanosecond Pulsed Laser Micro-Machining (Invited Presentation) (M206)

*Duncan Hand, Heriot-Watt University*

### High Precision Femtosecond Laser Fabrication for Micro-Nanodevices (Invited Presentation) (M207)

*Hong-Bo Sun, Jilin University*

### Optically Controlled Assembly of Single-Walled Carbon Nanotube Devices (M208)

*Wei Xiong, Y.S. Zhou, M. Mahjouri-Samani, M. Mitchell, Y.F. Lu, University of Nebraska-Lincoln*

## Micro Session 3: Laser Micromachining and Simulations

Wednesday, March 24 • 9:00am

*Session Co-chairs: Craig Arnold, Princeton University, Princeton, NJ, USA; Alberto Pique, Naval Research Laboratory, Washington D.C., USA*

### Formation of Periodic Nanostructures During Femtosecond Laser Ablation of Ceramic (Invited Presentation) (M301)

*Sungho Jeong, Gwangju Institute of Science and Technology*

### Nanostructuring Solid Surface with Femtosecond Laser Irradiations (Invited Presentation) (M302)

*Mengyan Shen, University of Massachusetts, Lowell*

### Process Competition in the Micromachining of Brittle Components (M303)

*Kristian Andreini, Magdi Azer, Peter J. Bednarczyk, Nitin Gard, Steven R. Hayashi, J. Eric Tkaczyk, GE Grc; Haochuan Jiang, GE Healthcare; Wenwu Zhang, GE Global Research*

## High Precision Femtosecond Laser Prototyping of Micro-Optical Components (M304)

*Qi-Dai Chen, Jilin University*

## Femtosecond Laser Fabrication of Fiber Microresonator Sensors: Experiments and Modeling (Invited Presentation) (M305)

*Xin Li, Lan Jiang, Sumei Wang, Beijing Institute of Technology; Yongfeng Lu, University of Nebraska-Lincoln; Hai-Lung Tsai, Hai Xiao, Missouri University of Science and Technology*

## Shock Waves in Laser-Assisted Near-Field Surface Nanostructuring (Invited Presentation) (M306)

*Xinwei Wang, Iowa State University*

## Molecular Dynamics Simulations of Femtosecond Pulse Laser Ablation of Metal Films (M307)

*Xiaodong Wang, Jinsong Liu, Shenglie Wang, Wuhan National Laboratory for Optoelectronics, Huazhong University of Science and Technology*

## Modeling and Investigating of Shock Pressure for Microscale Laser Shock Processing (M308)

*Zhigang Che, Shuili Gong, Shikun Zou, Ziwen Cao, Liangcai Xiong, Beijing Aeronautical Manufacturing Technology Research Institute (BAMTRI)*

## Micro Session 4: Laser Micro Structuring

Wednesday, March 24 • 1:30pm

*Session Co-chairs: Yoshiro Ito, Nagaoka University of Technology, Nagaoka, Niigata, Japan; Xinwei Wang, Iowa State University, Ames, IA, USA*

## Material Discovery with High Throughput Pulsed Laser Deposition (Invited Presentation) (M401)

*Samuel Mao, Lawrence Berkeley National Lab*

## Ultrafast Laser Processing of Nanomaterials in Liquids for Biomedical Applications (Invited Presentation) (M402)

*Michel Meunier, Ecole Polytechnique*

## Micro Machining Applications in Semiconductor, Photovoltaics and Flat-Panel-Display Industry (M403)

*Sascha Weiler, TRUMPF Laser- und Systemtechnik*

## Excimer Laser-Induced Quantum Well Intermixing in SiO<sub>2</sub> Coated InP/InGaAs/InGaAsP Microstructures (M404)

*Neng Liu, Khalid Moumanis, Jan J. Dubowski, Université de Sherbrooke*

## Laser-Assisted Surface Functionalization (Invited Presentation) (M405)

*Wilhelm Pfleging, Robert Kohler, Michael Stueber, Sven Ulrich, Michael Bruns, Johannes Schneider, Alexander Welle, Karlsruhe Institute of Technology*

## Generation of Hydrophobic Cones on Polyimide by Nd:YLF Texturing (Invited Presentation) (M406)

*Brandon Least, David Willis, Southern Methodist University*

## Femtosecond Laser Induced Superhydrophobic Transformation on Metal Surface (Invited Presentation) (M407)

*Ming Zhou, Jiangsu University*

## Superhydrophobic Surfaces with Microscale and Nanoscale Structures Prepared by Femtosecond Laser (M408)

*Wenjun Wang, Gedong Jiang, Xuesong Mei, Kedian Wang, Chengjuan Yang, Xi'an Jiaotong University*

## Micro Session 5: Ultrafast Laser Processing

Thursday, March 25 • 9:00am

Session Co-chairs: Kevin Chen, Beijing Golden Way Scientific Co., Ltd., Beijing, People's Republic of China; Koji Sugioka, RIKEN, Saitama, Japan

**Femtosecond Laser-Driven Shock Quenching of High-Pressure Phases of Materials (Invited Presentation) (M501)**

Tomokazu Sano, Osaka University

**Forming Limit and Fracture Mode of 3D Micro-Nanoscale Laser Dynamic Forming (Invited Presentation) (M502)**

Gary Cheng, Purdue University

**Several Novel Applications of Femto Second Laser (M503)**

Jeng Ywan Jeng, National Taiwan University of Science and Technology

**3D Nano and Micro Structures in Transparent Materials by In-Volume Femtosecond Laser Processing (Invited Paper) (M504)**

Dennis Beckmann, Dagmar Esser, Jens Gottmann, Maren Hörstmann-Jungemann, Martin Hermans, Ingomar Kelbassa, Dirk Wortmann, RWTH Aachen University

**Nanoaquarium Fabricated by Femtosecond Laser 3D Micromachining: Investigation on Phormidium Assemblage (Invited Presentation) (M505)**

Koji Sugioka, Yasutaka Hanada, Katsumi Midorikawa, Hiroyuki Kawano, Ikuko Ishikawa, Riken - ASI; Atsushi Miyawaki, Riken - BSI

**Machining of Optical Freeform Optics (Invited Presentation) (M506)**

Fengzhou Fang, Tianjin University

**Robust Optical Fiber Grating Achieved with Femtosecond Laser Exposure (M507)**

Chao Chen, Hong-Bo Sun, Jilin University

**Effects of Electron-Phonon Coupling Strength and Electron Density of States on Depth of Nanograting Structures Induced by Intense Femtosecond Pulsed Laser (M508)**

Zhihua Li, Haiyan Gao, Haixia Li, Huazhong University of Science and Technology

## Micro Session 6: Micromachining II and Novel Laser Sources

Thursday, March 25 • 1:30pm

Session Co-chairs: Samuel Mao, Lawrence Berkeley National Lab, Berkeley, CA, USA; Henry Peng, GE (China) Research & Development Center Co. Ltd., Shanghai, People's Republic of China

**Novel Fusion Welding Technology of Glass Using Ultrashort Pulse Lasers (Invited Presentation) (M601)**

Isamu Miyamoto, Osaka University; K. Cvecek, M. Schmidt, Bayerisches Laserzentrum GmbH; Y. Okamoto, Okayama University

**Selective Laser Melting for Rapid Prototyping of Medical Devices (Invited Presentation) (M602)**

Yongqiang Yang, South China University of Technology

**Progress in Laser-Induced Backside Wet Etching (Invited Presentation) (M603)**

Hiroyuki Niino, AIST

**High Throughput Micro Machining Due to Parallel Laser Processing (M604)**

Oliver Haupt, Rainer Kling, Frank Siegel, Laser Zentrum Hannover e.V.

**Photovoltaic and Semi-Conductor Applications: Advantages of Using a Low M<sup>2</sup>, Short Pulse Width, High Average Power and High Repetition Rate Q-Switched Nanosecond DPSS Laser (Invited Presentation) (M605)**

Rajesh Patel, Spectra Physics, Division of Newport Corporation

**Micro-machining with Nanosecond Pulsed Fiber Laser Beams (Invited Presentation) (M606)**

Jack Gabzdyl, SPI Lasers

**A New, Flexible Ultrafast Laser for Process Development in Micromachining Applications (M607)**

Eric Mottay, Antoine Courjaud, Martin Delaigue, Amplitude Systemes

**Properties and Industrial Applications of Picosecond Laser (M608)**

Jianke Di, Liang Guo, Haibin Xu, Yuxing Zhao, Suzhou Delphi Laser Co, Ltd.

**Fiber Lasers for Micro-Machining Tasks (M609)**

Tony Hoult, IPG Photonics Corporation

## Poster Presentation Gallery

### Poster Presentation Gallery

Wednesday, March 24th and Thursday, March 25th

**Laser Patterning in Thin Film Solar (P102)**

Wang Minfeng, Zhao Yuxing, Suzhou Delphi Laser Co., Ltd.

**Laser Scribing of Thin Film Solar Panels (P103)**

Xiangyang Song, JPSA

**Ultrafast Laser Microprocessing of Metal and Silicon at 1030 Nm and 515 Nm (M103)**

Charly Loumena, John Lopez, Alphanov; Yoann Zaouter, Martin Delaigue, Eric Mottay, Amplitude Systemes

**Development and the Application of the Ships Using the Advanced Optical Material (P105)**

Zhang Yu, Luoyang Ship Material Research Institute

**Nanoparticle Selective Laser Sintering for Large Area Flexible Electronics Fabrication with a Scanning Mirror (P106)**

Seung Hwan Ko, Junyeob Yeo, Kaist; Nico Hotz, Heng Pan, Costas Grigoropoulos, UC Berkeley

**Ultraviolet Laser Characteristic and Its Application in Laser Processing (P107)**

Jianke Di, Yuxing Zhao, Liang Guo, Haibin Xu, Suzhou Delphi Laser Co., Ltd.

**Effects of Tailored Nanosecond Pulsed Fiber Laser Beam Modes on Micro-Machining. (P108)**

Jack Gabzdyl, SPI Lasers

**Application of Femtosecond Optical Frequency Comb's Temporal Coherence Character to a Distance Estimation (P109)**

Dong Wei, Satoru Takahashi, Kiyoshi Takamasu, Hirokazu Matsumoto, The University of Tokyo

**Rapid Prototyping of Gas Sensor on Alumina Substrate by Laser Micro Cladding Electronic Materials (P110)**

Xiaoyan Zeng, Wuhan National Laboratory for Optoelectronics; Cai Zhixiang, Huazhong University of Science and Technology

**A Study of 355Nm DPSS UV Laser Micromachining for Silicon Wafer (P111)**

*Fei Zhang, Jun Duan, Xiaoyan Zeng, Xiangyou Li, Huazhong University of Science and Technology*

**Study on Microscale Laser Peen Forming of Copper Foil Based on Numerical Simulation and Orthogonal Experimental Design (P112)**

*Chao Zheng, Sheng Sun, Zhong Ji, Jing Liu, Wei Wang, Shandong University*

**Dynamic Fractures in Microscale Laser Peen Forming (P113)**

*Jing Liu, Zhong Ji, Chao Zheng, Wei Wang, Shandong University*

**Refractive Micro-Optical Components Produced by Two-Photon Photopolymerization of Resins (P115)**

*Xiao-Feng Lin, Hong-Bo Sun, Jilin University*

**Femtosecond Laser Nanofabrication of Field Effect Transistors from Graphene Oxides (P116)**

*Li Guo, Hong-Bo Sun, Jilin University*

**Three-Dimensional Metal Nanowiring by Femtosecond Laser-Induced Photoreduction from Solution (P117)**

*Bin-Bin Xu, Hong-Bo Sun, Jilin University*

**Beam Shaping of Vertical Cavity Surface Emitting Laser Diodes by Aspheric Microlenses and Microlens Arrays (P118)**

*Niu, Jilin University*

**Ablation of Optical Fiber (P119)**

*Wenbin Hu, Fan Bai, Wuhan University of Technology*

**Morphological and Optical Properties of Silicon Nanoparticles Grown by Pulsed Laser Deposition (P120)**

*Lalit Kukreja, R R Centre for Advanced Technology*

**Theoretical Study of Spontaneous Polarization in BiFeO<sub>3</sub> Crystal (P121)**

*N. Sisodia, H.S. Dagar, P. Sen, Holkar Science College*

**KRF Laser Irradiation Effect on Properties of ZnO Thin Films (P122)**

*Yan Zhao, Beijing University of Technology*

**Laser in Satellite Remote Sensing (P123)**

*Mohammad Anwar, Dhaka University*

**Selective Laser Sintering: Recent Advances (P124)**

*Sanjay Kumar, CSIR, South Africa*

**Analytical Calculation of Laser Surface Hardening with a Circle Beam (P125)**

*Binggong Yan, Jichang Liu, Hunan University*

**Using EAM to Simulate Interaction of Intense Laser LIBS in Lead (P126)**

*Yinfei Lu, Rao Fu, Guizhong Zhang, Degang Xu, Jianquan Yao, College of Precision Instrument and Optoelectronics Engineering Tianjin University*

**A New Control System in Laser Hardening (P127)**

*Caixia Yang, Hunan University*

**High Accuracy Medium Range Laser Range Finder Design (P128)**

*Junewen Chen, Chung-Hua University*

**A Method of Measuring High Temperature Based on Emission Spectrum (P129)**

*Jianmin Miao, Jianhua Yao, Xiaodong Hu, Chenghua Sui, Zhejiang University of Technology*

**Research on Compound Treatment of 35CrMoA Steel by Laser Quenching and Nitriding (P130)**

*Han Bin, Wang Yong, China University of Petroleum*

**Laser Net Shape Manufacturing Of Superalloy Rene 80 (P131)**

*Yanmin Li, Yong Liu, Henry Peng, GE (China) Research & Development Center Co., Ltd.*

**The Processing Techniques for a Novel Non-Planar Four Frequency Ring Laser Gyro (P132)**

*Jian-Qiang Yang, Dan Liao, College of Opto-Electronics Science and Engineering, National University of Defense Technology; Xin Jin, Chinese Army of No. 91746; Yun Luo, Weaponry Department of Engineering, Naval University of Engineering; Yong Zhu, Academy of Air Force Radar*

**An Application Study of Galvanometric Scanner with Computer Based Dynamic Focus in Rapid Prototyping (P133)**

*Wen Shifeng, Huazhong University, College of Science & Technology*

**Which Laser Source for Micromachining Applications? (P135)**

*Mohammed Naeem, GSI Group, Inc. - Laser Division*

**Laser Forming Repair of Ti-6Al-4V Alloys (P136)**

*Lei Xue, Northwestern Polytechnical University*

**Study on Directly Forming Metallic Component Through Selective Laser Melting (P137)**

*Ruidi Li, Yusheng Shi, Zhigang Wang, State Key Laboratory of Material Processing and Die & Mould Technology, Huazhong University of Science and Technology; Jinhui Liu, Modern Manufacture Engineering Center, Heilongjiang University of Science and Technology*

**Laser Hardening of Ductile Cast Iron (P138)**

*Jichang Liu, Hunan University*

**Cutting Glass Substrates in Melting Means with Dual Laser Beams (P140)**

*Junke Jiao, Changwen Peng, Xiaobo Bai, Ju Dai, Institute of Industry Technology, Guangzhou and Chinese Academy of Sciences; Xinbing Wang, Huazhong University of Science and Technology*

**Research on Machine Vision of Molten Pool Temperature Field in Laser Remanufacturing Robot (P141)**

*Xichen Yang, Laser Processing Center, Tianjin Polytechnic University*

**Effects of Laser Drilling on Rate of Penetration (ROP) for Oil and Gas Wells Drilling (P144)**

*Mahdi Bakhtbidar, Mohsen Ghorbankhani, Islamic Azad Univeristy Branch of Omidieh*

**Research of Shielding Gas Flow Field on Laser Coaxial Powder Feeding Nozzle (P145)**

*Dexian Yi, Fangyou Hu, Naea Qingdao Brach*

**Fabrication of Metal Network on Titanium Diaphragm for Tweeter Speaker by Laser Selected Surface Alloying (P147)**

*Aikui Li, (unknown); Xiaoyan Zeng, HUST*

**Direct Laser Writing System of Mask for Integrated Photonics Devices (P148)**

*Slimane Messaoud, CDTA; Abdelkrim Allam, Fodil Siserir, Yacine Bouceta, Tahar Kerdja, Tahar Touam, Centre de Developpement des Technologies Avanc Es; Djamel Oudjaout, Unit de Developpement de La Technologie du Silicium*

**A New Control System for Laser Cladding (P150)**

*Jichang Liu, Liusha Yang, Hunan University*

**Microstructures of Alloyed and Dispersed Hard Particles in the Aluminium Surface (P151)**

*Sisa Pityana, CSIR National Laser Centre*

**Femtosecond Laser Internal Structuring of Materials using a Spatial Light Modulator (P152)**

*Dun Liu, Walter Perrie, Zheng Kuang, S. P. Edwardson, Laser Group; Patricia Scully, A. Baum, Shijie Liang, Anca Taranu, Photon Science Institute*

**The Effect of Laser Scanning Path on Microstructure and Properties of Laser Solid Formed Nickel-Base Superalloy Inconel 718 (P153)**

*Fencheng Liu, Xin Lin, Gaolin Yang, Jing Chen, Weidong Huang, Northwestern Polytechnical University*

**A Review of Laser Assisted Machining of Metals (P154)**

*Shoujin Sun, Swinburne University of Technology*

**Synthesis of Doped-Zno Nanowires by Laser Ablation and Their Application to Light Emitting Devices (P157)**

*Tatsuo Okada, Kyushu University*

**Femtosecond Laser Micromachined Polymer Surface: Cell Adhesion Study (P159)**

*Ka Lai Ng, SIMTech; Wai Yee Yeong, School of Materials Science and Engineering, Nanyang Technological University*

**Optimization of Preparation Parameters and Resistivity of Lifepo<sub>4</sub> Thin Films by Pulsed Laser Deposition (P165)**

*Zhihua Li, Mingtao Huang, Duanming Zhang, School of Physics, Huazhong University of Science and Technology*

**Femtosecond Laser Induced Superhydrophobic Transformation on Metal Surface (P166)**

*Ming Zhou, Li Baojia, Li Jian, Yuan Run, Jiangsu University*

## General Information

### Hotel Accommodations

#### Shangri-La Hotel

700 Jianshe Avenue  
Hankou, Wuhan 430015  
People's Republic of China  
Tel: (86 27) 8580 6868  
Fax: (86 27) 8572 5698  
Website: www.shangri-la.com

Hotel reservations need to be made directly with the Shangri-La Hotel.

### Conference Registration

Registration can be completed in two ways – online or by downloading a PDF registration form from [www.laserinstitute.org/picalo](http://www.laserinstitute.org/picalo)

Full conference registration includes: Plenary Session, Technical Sessions, Welcome Reception (Tuesday evening), Vendor Program Reception (Wednesday evening) and a Technical Digest. Conference Proceedings are available for an additional fee. Registration also includes morning and afternoon coffee service, Chinese style lunch, and the PICALO Closing Banquet (Thursday evening).

One Day Conference Registration includes admission to sessions and receptions on that day only. Proceedings are available for an additional fee.

Student Registration includes: Plenary Session, Technical Sessions, Welcome Reception (Tuesday evening), Vendor Program Reception (Wednesday evening) and a Technical Digest. Conference Proceedings are available for an additional fee. Registration also includes morning and afternoon coffee service, Chinese style lunch, and the PICALO Closing Banquet (Thursday evening).

Please contact the LIA Conference Department at [picalo@laserinstitute.org](mailto:picalo@laserinstitute.org) for more information about Guest Tickets.

### Proceedings

CD-Rom Proceedings will be available on-site (will not be shipped to you). It includes all submitted papers from PICALO – Laser Materials Processing, Micro, Nano & Ultrafast Fabrication and Poster Presentations.

Payment Received by February 1: \$115 USD

February 2 – On-site: \$125 USD

*\*Please note: all payments will be processed in US Dollars.*

### Special Needs

If you have any special needs that we can address to make your participation more enjoyable, please contact LIA by

Phone: +1. 407.380.1553, Fax: +1. 407.380.5588 or Email: [picalo@laserinstitute.org](mailto:picalo@laserinstitute.org)

### Substitutions and Cancellations

We understand that circumstances may occur to prevent you from attending the conference. If you find that you cannot attend PICALO, you have several options:

1. Send a substitute. Substitutions can be made at any time – even on-site at the conference. (Please have the substitute bring your letter of confirmation to the registration desk).
2. Refund of monies. \*

*\*Note: Requests must be made in writing and received on or before February 1. There is a \$75.00 processing fee applied to all refunds. All refunds will be processed after the conference. No refunds will be accepted after February 1.*

### Average March Temperatures:

High 57°F / 14°C

Low 42°F / 5°C

### Fees

#### Full Conference – Early Bird Registration

(payment received by January 21)

\$595 USD Member	\$655 USD Non-Member
\$595 USD Cooperating Society	\$325 USD Student
\$250 USD (1,750 CNY) Chinese Citizen	
\$224 USD (1,500 CNY) Chinese Citizen Student	

#### January 22 – February 18

\$645 USD Member	\$705 USD Non-Member
\$645 USD Cooperating Society	\$375 USD Student
\$290 USD (2,000 CNY) Chinese Citizen	
\$265 USD (1,825 CNY) Chinese Citizen Student	

#### February 19 – On-site

\$695 USD Member	\$755 USD Non-Member
\$695 USD Cooperating Society	\$425 USD Student
\$315 USD (2,150 CNY) Chinese Citizen	
\$290 USD (2,000 CNY) Chinese Citizen Student	

#### One Day Conference Registration - Early Bird Registration

(payment received by January 21)

\$220 USD each day  
\$150 USD (1,025 CNY) Chinese Citizen

#### January 22 – February 18

\$250 USD each day  
\$170 USD (1,175 CNY) Chinese Citizen

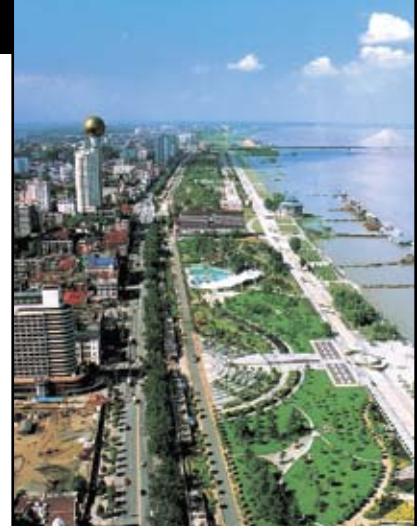
#### February 19 – On-site

\$285 USD each day  
\$190 (1,300 CNY) Chinese Citizen

#### On-site Registration Times

Monday, March 22	2:00pm – 5:00pm
Tuesday, March 23	8:00am – 5:00pm
Wednesday, March 24	8:00am – 5:00pm
Thursday, March 25	8:00am – 12:00pm

*\*Purchase orders will not be accepted for on-site registration*





PACIFIC INTERNATIONAL CONFERENCE  
ON APPLICATIONS OF LASERS & OPTICS

Mail or Fax to:  
Laser Institute of America  
13501 Ingenuity Dr., Suite 128  
Orlando, FL 32826  
Phone: 407.380.1553  
Fax: 407.380.5588

For Office Use Only  
Date: \_\_\_\_\_ Amt. Rcv'd \_\_\_\_\_  
ID # \_\_\_\_\_

### REGISTRATION FORM

All prices in United States Dollars (USD)  
Chinese Citizen Registration Prices Available on PICALO registration page.  
Register Online at [www.laserinstitute.org/picalo](http://www.laserinstitute.org/picalo)

Please check here if you are a first time PICALO attendee.

PLEASE PRINT OR TYPE  Prof.  Dr.  Mr.  Mrs.  Ms.  Miss

First Name/M.I./Last Name (Surname): \_\_\_\_\_

Business Affiliation: \_\_\_\_\_

Dept./Bldg./Mail Stop/etc.: \_\_\_\_\_

Street Address or P.O. Box: \_\_\_\_\_

City/State/Zip (Postal) Code: \_\_\_\_\_ Country: \_\_\_\_\_

Telephone (Work): \_\_\_\_\_ Fax: \_\_\_\_\_

E-mail: \_\_\_\_\_

Emergency Contact Name: \_\_\_\_\_ Telephone: \_\_\_\_\_

Membership Status:  LIA Corporate Member  LIA Individual Member (*Membership must be valid through March to take advantage of member rates.*)

Check here if you have any special needs and LIA will contact you.  
 Check here if you do not want your name on the published PICALO attendee mailing list.

You may also register online at  
[www.laserinstitute.org/picalo](http://www.laserinstitute.org/picalo)

### Full Registration

*Includes admission to Plenary Session, Technical Sessions, Lunch each day, Welcome Reception, Vendor Program Reception, Closing Banquet & Technical Digest.*

Check member status:  LIA  AILU  ELI  European Optical Society  Chinese Journal of Lasers  Beijing Optical Society

Membership # \_\_\_\_\_

	LIA Member/Cooperating Society	Non-member	Student
Payment postmarked or received by January 21	___ \$595 USD	___ \$655 USD	___ \$325 USD
Payment postmarked or received by Jan. 22 – Feb. 18	___ \$645 USD	___ \$705 USD	___ \$375 USD
Payment postmarked or received by Feb. 19 – On-site	___ \$695 USD	___ \$755 USD	___ \$425 USD

**\*Student registration – full time students only. Student registration will not be processed without a copy of your valid Student Identification.  
Please fax to +407.380.5588 Attn: PICALO**

### One Day / Two Day Registration

*Includes lunch and admissions to events on that day only.*

Date(s) must be checked to process registration:  Tuesday March 23  Wednesday March 24  Thursday March 25

Payment postmarked or received by January 21	___ \$220 USD One Day
Payment postmarked or received by Jan. 22 – Feb. 18	___ \$250 USD One Day
Payment postmarked or received by Feb. 19 – On-site	___ \$285 USD One Day

### Guests

*Includes lunch each day, coffee breaks, Welcome Reception, Vendor Program Reception and Closing Banquet.*

\$130 USD x \_\_\_\_\_ (# of guests) = \$ \_\_\_\_\_ Name of guest(s): \_\_\_\_\_  
(Please provide for nametag purposes)

### Proceedings

*CD-ROM Proceedings will be available on-site (will not be shipped to you). Includes all submitted manuscripts.*

Received by February 1 \_\_\_ \$115 USD  Received February 2 - On-site \_\_\_ \$125 USD

### Method of Payment

*Payment must accompany registration form to be processed. Confirmation e-mail will be sent within two weeks of receipt.*

*(Please include registrant's name and PICALO on check.)*

VISA  Mastercard  AMEX  Check or Money Order enclosed, Payable to LIA in U.S. Funds, Drawn on a U.S. Bank

Amount Authorized: USD \$ \_\_\_\_\_ Credit Card No. \_\_\_\_\_

Name on Card: \_\_\_\_\_ Exp. Date: \_\_\_\_\_ Card Security Code\*:

Authorized Signature: \_\_\_\_\_ Date: \_\_\_\_\_

**\*The card security code (CSC) is a 3- or 4- digit number (not part of the credit card number) that appears on the back of VISA and MasterCard & the front of American Express credit cards. Payment can not be processed without CSC number.**

Refund policy: No refunds will be made on cancellations received after February 1st. All requests for refunds must be made in writing. There will be a \$75.00 USD processing fee for all refunds. Proceedings will not be refunded.



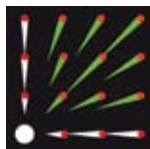
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Laser Applications and Safety

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## PICALO Advance Program 2010 [www.laserinstitute.org/picalo](http://www.laserinstitute.org/picalo)



### Important Planning Information

While planning for your trip to Wuhan to attend PICALO 2010, please note that LASER WORLD of Photonics China and the 5th Laser Processing & Components Conference will be held a week prior in Shanghai, March 16-18, 2010 at Shanghai's New International Expo Centre.

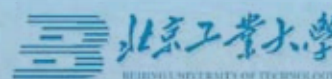
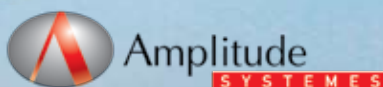
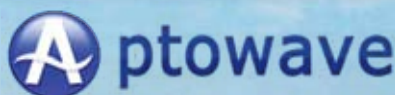
To find out more about the LIA supported Laser Processing & Components Conference visit <http://world-of-photonics.net/link/en/19772231>.

To find out more about LASER WORLD of Photonics China visit [www.world-of-photonics.net/en/laser-china/start](http://www.world-of-photonics.net/en/laser-china/start).

**LASER** World of **PHOTONICS** CHINA

## Sincere Thanks to our PICALO 2010 Sponsors:

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### Who Should Attend PICALO?

Anyone interested in lasers and materials processing from the basic understanding of the interaction between a laser beam and a material to those interested in how a process can be integrated and optimized for an application should attend PICALO. The organizing committee's goal for PICALO is to bring both academic and industry people together who may benefit from laser technology. This includes researchers and end-users as well as engineers and technicians engaged in developing laser technology. The conference will provide a face-to-face platform for scholars, experts and entrepreneurs worldwide as well as management personnel, technicians, and end-users in China, especially in Wuhan. At the same time, PICALO will demonstrate the development and achievements in the field of laser processing in recent years and thus bridge China's companies and enterprise to the world.